

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant(s): SAKAKIBARA | Atty. Dkt.: 01-278-DIV |
| Serial No.: Unknown | Group Art Unit: |
| Filed: Concurrently herewith | Examiner: |
| Title: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE | |

Commissioner for Patents
Arlington, VA 22202

Date: October 30, 2003

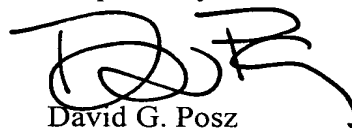
INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are being submitted for consideration by the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

The Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,



David G. Posz
Reg. No. 37,701

Posz & Bethards, PLC
11250 Roger Bacon Drive, Suite 10
Reston, VA 20190
(703)707-9110 (phone)
Customer No. 23400

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| FORM PTO-1449 | ATTY. DKT NO. | 01-278-DIV | SER. NO. |
| | APPLICANT | SAKAKIBARA | |
| | FILING DATE | October 30, 2003 | GROUP |

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB CLASS |
|---------------------|--|--------------------|---------------|------------------|-------|--------------|
| | | 6,525,375 | Feb. 25, 2003 | Yamaguchi et al. | | |
| | | 5,216,275 | June 1, 1993 | Chen | | |
| | | 5,438,215 | Aug. 1, 1996 | Tihanyi | | |
| | | 5,828,101 | Oct. 27, 1998 | Endo | | |
| | | 6,281,547 | Aug. 28, 2001 | So et al. | | |

FOREIGN PATENT DOCUMENTS

TRANSLATION

| | | DOCUMENT NUMBER | DATE | COUNTRY | NAME | CLASS | SUB CLASS | YES | N O |
|--|--|------------------|----------|---------|------|-------|--------------|-----------------|--------|
| | | JP-A-4-162572 * | 6/8/92 | JAPAN | | | | X (Abstract) | |
| | | JP-A-61-125174 * | 6/12/86 | JAPAN | | | | X (Abstract) | |
| | | JP-A-5-82782 * | 4/2/93 | JAPAN | | | | X (Abstract) | |
| | | JP-A-8-204195 * | 8/9/96 | JAPAN | | | | X (Abstract) | |
| | | JP-A-10-214969 * | 8/11/98 | JAPAN | | | | X (Abstract) | |
| | | JP-A-11-103058 * | 4/13/99 | JAPAN | | | | X (Abstract) | |
| | | JP-A-11-150265 * | 6/2/99 | JAPAN | | | | X (Abstract) | |
| | | JP-A-3-283669 * | 12/13/91 | JAPAN | | | | X (Abstract) | |
| | | JP-A-64-9662 * | 1/12/89 | JAPAN | | | | X (Abstract) | |
| | | JP-A-63-66963 * | 3/25/88 | JAPAN | | | | X (Abstract) | |

* Full English text of the JP Document will be available in machine-translated form from JP (Japanese Patent Office) English language web site at <http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX>.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

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| | | |
| EXAMINER | | DATE CONSIDERED |